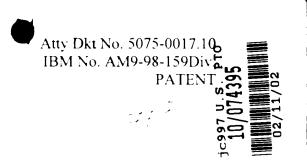
Thereby certify that this paper or fee — being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR § 1.10 on the date indicated below and is addressed to "Commissioner for Patents, Washington, DC 20231."

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Craig Jon HAWKER et al.

Divisional of Serial No.: 09/261,300

Group Art Unit: Unassigned

Filing Date: Concurrently herewith

Examiner: Unassigned

Title: SUBSTRATES PREPARED BY CHEMICAL AMPLIFICATION OF

SELF-ASSEMBLED MONOLAYERS WITH SPATIALLY LOCALIZED POLYMER

BRUSHES (as amended herewith)

## Information Disclosure Statement

Commissioner for Patents Washington, DC 20231

Sir:

This is an Information Disclosure Statement submitted for the Examiner's consideration. Applicants respectfully request that the Examiner review and make of record the references identified below.

The references identified below were disclosed and/or cited in parent application Serial No. 09/261,300, filed March 2, 1999, and, as such, copies thereof are not included pursuant to the provisions of 37 CFR § 1.98(d).

A PTO-1449 form listing the references accompanies this paper. Applicants would appreciate the Examiner's initialing and returning the form to indicate that the references have been reviewed and made of record. The references are as follows:

U.S. PATENT DOCUMENTS		
Patent No.	Issue Date	Patentee
5,512,131	4 30 96	Kumar et al.
. 5,620,850	4 97	Bamdad et al.
5,869,135	2 99	Vaeth et al.

## OTHER DOCUMENTS

Delamarche et al. (1998), "Transport Mechanisms of Alkanethiols During Microcontact Printing on Gold," *J. Phys. Chem. B.* 102:3324.

Hawley's Condensed Chemical Dictionary, 12<sup>th</sup> Edition, p. 942, Van Nostrand Reinhold Company, New York (1993).

Jackman et al. (1995), "Fabrication of Submicrometer Features on Curved Substrates by Microcontact Printing," *Science* 269:664-666.

Kumar et al. (1992), "The Use of Self-Assembled Monolayers and a Selective Etch to Generate Patterned Gold Features," *J. Am. Chem. Soc.* 114:9188-9189.

Kumar et al. (1994), "Patterning Self-Assembled Monolayers: Applications in Materials Science," *Langmuir* 10(5):1498-1511.

Xia et al. (1998), "Soft Lithography," Angew. Chem. Int. Ed. 37:550-575.

This Information Disclosure Statement is not intended as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that any of the above references constitutes prior art to the present application within the meaning of 35 USC § 102.

As this Information Disclosure Statement is being filed concurrently with the application, no fee is required.

Respectfully submitted,

Date

By:

Dianne E. Reed

Registration No. 31,292

REED & ASSOCIATES 800 Menlo Avenue, Suite 210 Menlo Park, California 94025 (605) 330-0900 Telephone (650) 330-0980 Facsimile

2/11/02